

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Appl. No.: 10/565036 Confirmation No.: 7066
Applicant: BECKER, *et al.*
Filed: 18/JAN/2006
TC/A.U.: 2829
Examiner: Hung, Ming Hung
Docket No.: DC5146 PCT1
Customer No.: 00137
Date: 10 October 2008
For: Method for Etching a Patterned Silicone Layer

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

AMENDMENT

Sir:

In response to the office action dated 20 August 2008 please amend the above-identified application as follows.

Amendments to the Specification are on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on page 3 of this paper.

Remarks begin on page 7 of this paper.